



09/809181

GP 2812

503.39864X00

#4/Pr. Amnd A
DKing
9/5/08

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: **Toshiya SATOH et al.**

Application No.: **Not Yet Assigned**

Filing Date: **March 16, 2001**

Title: **SEMICONDUCTOR DEVICE AND MANUFACTURING METHOD THEREOF**

Art Unit: **Not Yet Assigned**

Examiner: **Not Yet Assigned**

PRELIMINARY AMENDMENT

Assistant Commissioner of Patents
Washington, D.C. 20231

August 20, 2001

RECEIVED
AUG 23 2001
TC 2806 MAIL ROOM

Sir:

Prior to examination, please enter thereto the following Preliminary Amendment.

IN THE SPECIFICATION:

Please amend the specification as follows:

Page 19, starting at line 11, insert - Fig. 38 is a view showing a semiconductor device according to first, third, forth, sixth, seventh and ninth embodiments of this invention and illustrates the structure of its substantial part.

Fig. 39 is a view showing a semiconductor device according to second, fifth and eighth embodiments of this invention and illustrates the structure of its substantial part.;

Fig. 40 is a view showing a semiconductor device according to tenth, fourteenth, sixteenth, seventeenth, eighteenth, twenty-second, twenty-sixth, twenty-eighth, twenty-ninth, thirtieth, thirty-second and thirty-third embodiments of this invention and illustrates the

A1